

Docket No.: 31721-219467  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Masaaki Nagatsu

Application No.: 10/539,279

Confirmation No.: 7365

Filed: June 16, 2005

Art Unit: 1792

For: MICROWAVE PLASMA GENERATOR

Examiner: Nathan K. Ford

*OK to  
file  
7/10/08*

**AMENDMENT AFTER FINAL REJECTION**

**MS AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed February 29, 2008, the period for responding to which having been extended for two months to July 29, 2007 by the concurrently filed Request for Extension of Time, please amend the Application as follows:

**Amendments to the Claims** are reflected in the Listing of the Claims which begin on page 2 of this paper.

**Remarks** begin on page 4 of this paper.